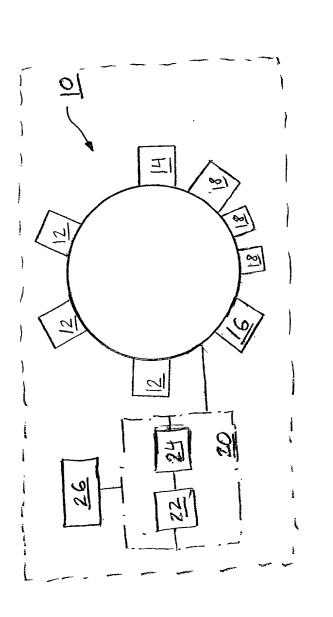
Title: Method and Apparatus For Controlling Dopant Concentration During BPSG Film Deposition To Reduce Nitride Consumption Inventor(s): Kevin Mukai, Shankar Chandran

Application No./Atty. Docket No.:4887.P518 - 5047



Title: Method and Apparatus For Controlling Dopant Concentration During BPSG Film Deposition To Reduce Nitride Consumption Inventor(s): Kevin Militar Shankar Ghandran Male 1918 - 5047

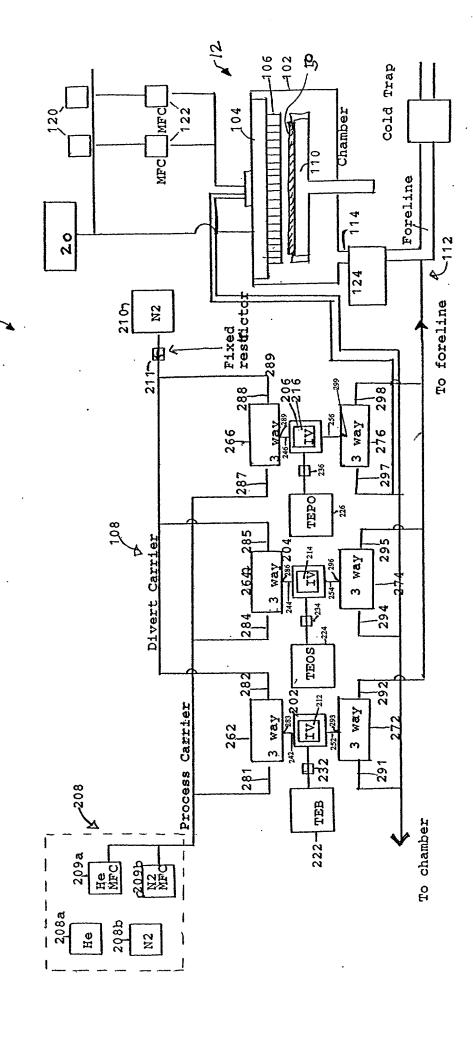


Figure 2

Inventor(s): Kevin Mukai, Shankar Chandran

Application No./Atty. Docket No.:4887.P518 - 5047

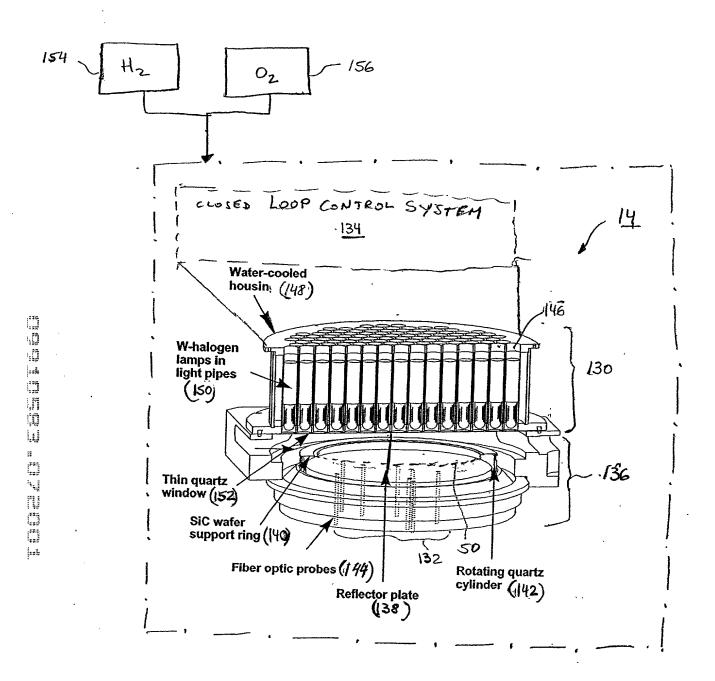
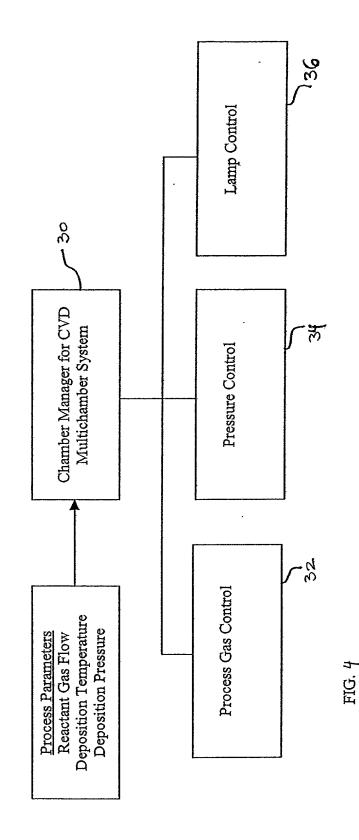


Fig. 3



Title: Method and Apparatus For Controlling Dopant Concentration During BPSG Film Deposition To Reduce Nitride Consumption Inventor(s): Kevin Mukai, Shankar Chandran Application No./Atty. Docket No.:4887.P518 - 5047

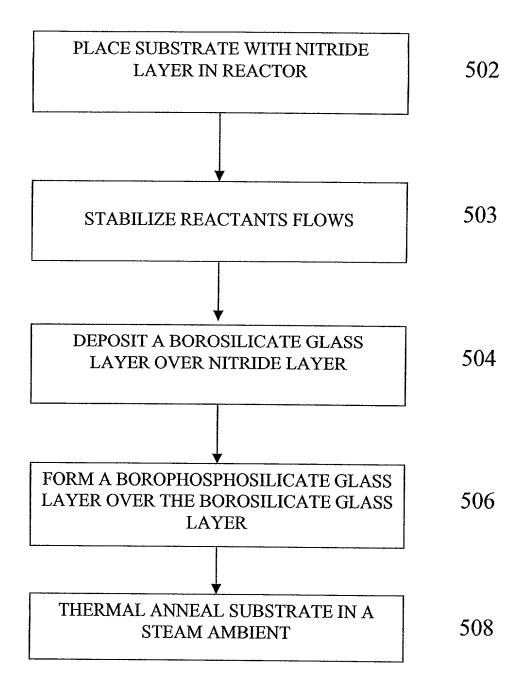
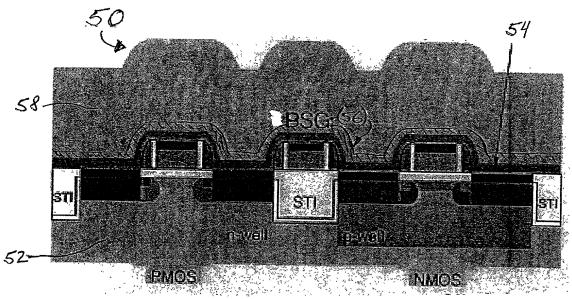


FIG. 5

Title: Method and Apparatus For Controlling Dopant Concentration During BPSG Film Deposition To Reduce Nitride Consumption Inventor(s): Kevin Mukai, Shankar Chandran Application No./Atty. Docket No.:4887.P518 - 5047



Fis. 6

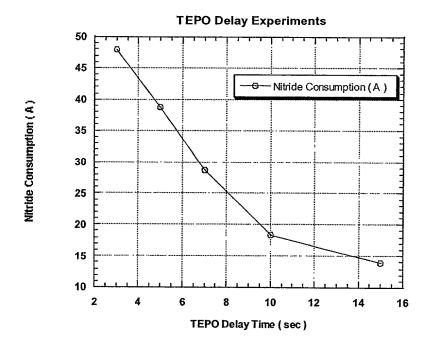


FIG. 7